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## \*BIBDATASHEET\*

Bib Data Sheet

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SERIAL NUMBER 10/751,503	FILING DATE 01/06/2004 RULE	CLASS 438	GROUP ART UNIT 2823	ATTORNEY DOCKET NO. LEEH3016/EM
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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

*Lee*  
*NONE*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

*Lee*  
*NONE*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 04/08/2004

Foreign Priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged	<i>Lee</i>	TAIWAN	4	10	2

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## TITLE

Method for forming shallow trench in semiconductor device

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue )
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